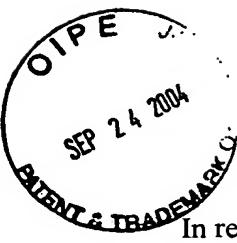


IFW



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Keji SHIGEMATSU et al.

Group Art Unit: 1752

Application No.: 10/611,966

Filed: July 3, 2003

Docket No.: 116404

For: PROJECTION OPTICAL SYSTEM, EXPOSURE APPARATUS, AND DEVICE
PRODUCTION METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. The references 1-2 were cited in a counterpart foreign application. An English language version of the foreign search report is attached for the Examiner's information.

Respectfully submitted,

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Date: September 24, 2004

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)			US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 116404		APPLICATION NO. 10/611,966	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)			APPLICANTS Keji SHIGEMATSU et al.					
			FILING DATE July 3, 2003		GROUP 1752			
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME		CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY		CLASS	SUB CLASS	
	1.	EP 1 139 138 A1	10/4/2001	EUROPE				
	2.	WO 02/31870 A1	4/18/2002	WIPO				
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)								
EXAMINER							DATE CONSIDERED	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								